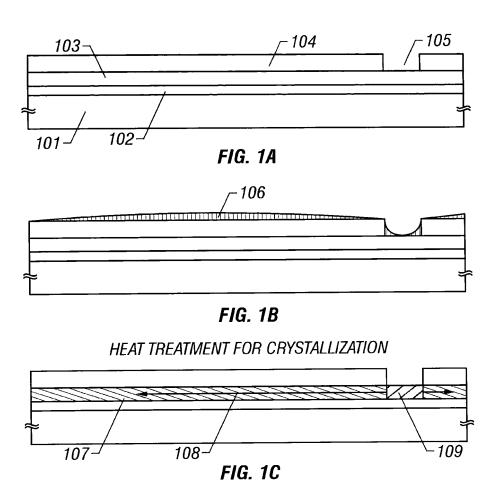
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HEAT TREATMENT IN ATMOSPHERE CONTAINING HALOGEN ELEMENT

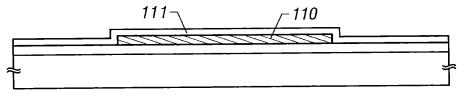


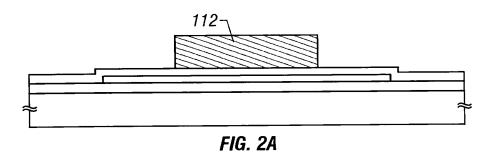
FIG. 1D

107515451 121501

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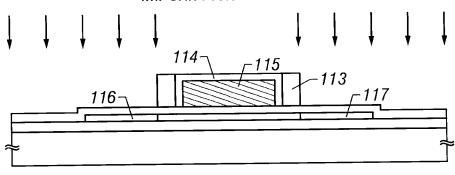
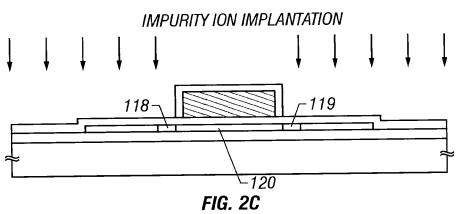


FIG. 2B



121 123 122

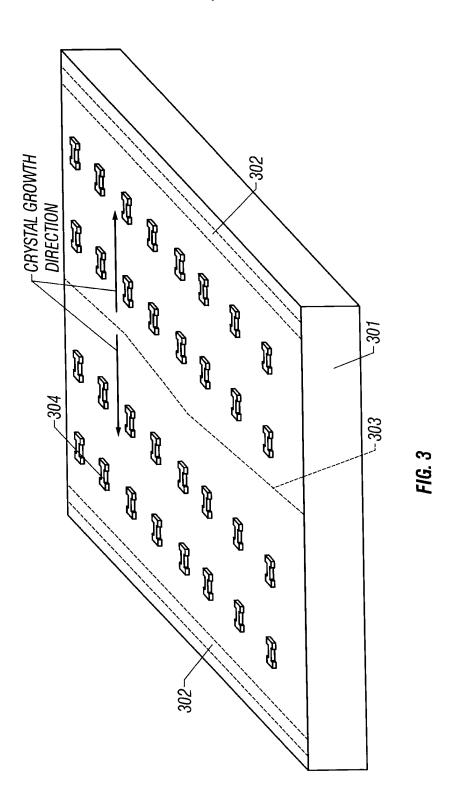
FIG. 2D

100EP455014 121801

Matter No.: 07977-188002

Cicant(s): Yamazaki et al.

CONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME



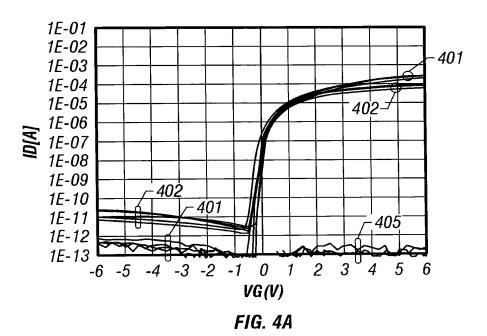
10754750 121801

Matter No.: 07977-188002 App (s): Yamazaki et al.

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MANUFACTURING THE SAME

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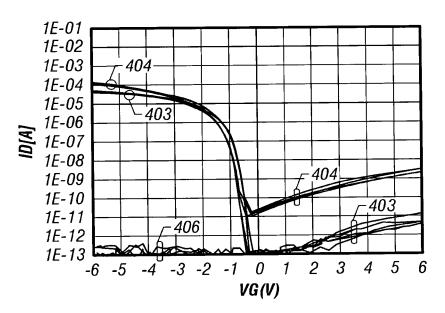


FIG. 4B

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MANUFACTURING THE SAME

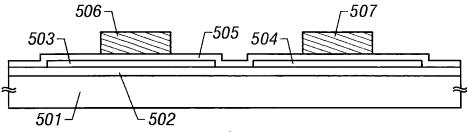


FIG. 5A

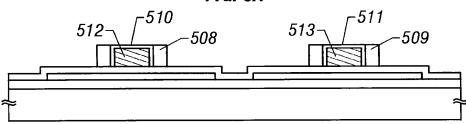


FIG. 5B

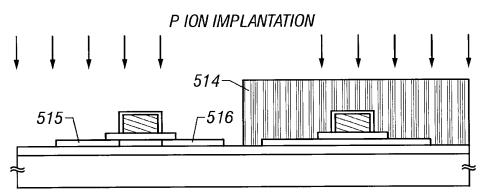
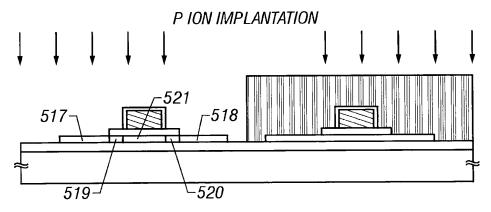


FIG. 5C



N-CHANNEL TYPE TFT

P-CHANNEL TYPE TFT

FIG. 5D

10124550.121801

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B ION IMPLANTATION

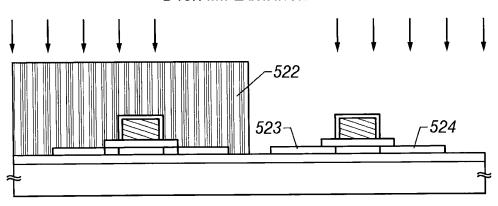


FIG. 6A

B ION IMPLANTATION

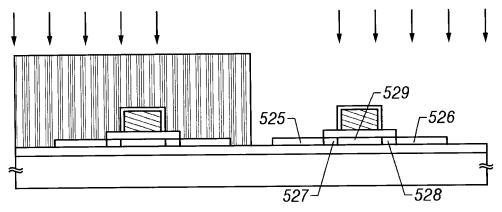


FIG. 6B

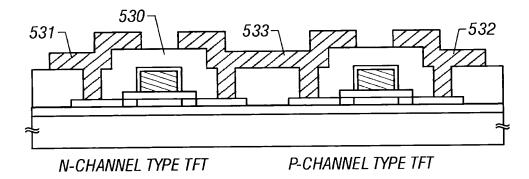


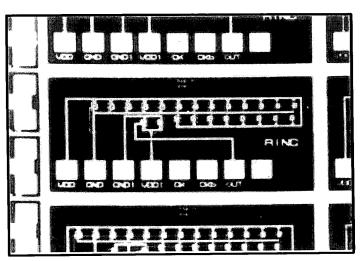
FIG. 6C

10074950 .121801

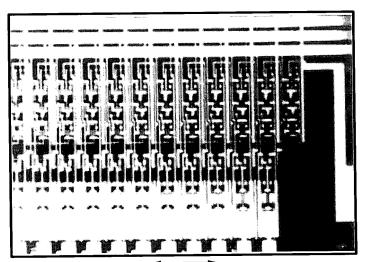
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CONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME



150μm **FIG. 7A**



150µm

FIG. 7B

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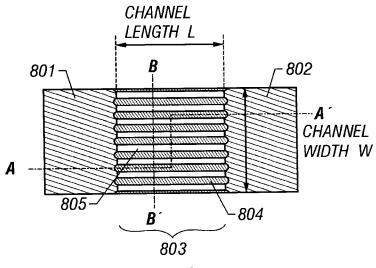


FIG. 8A

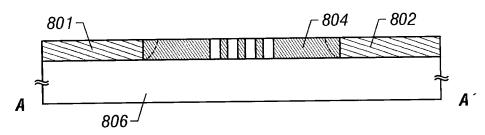
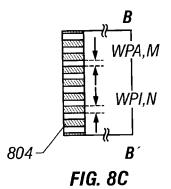
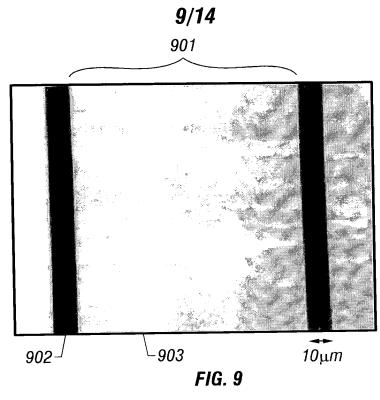


FIG. 8B



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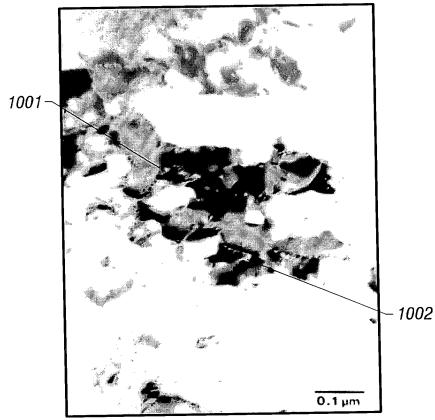
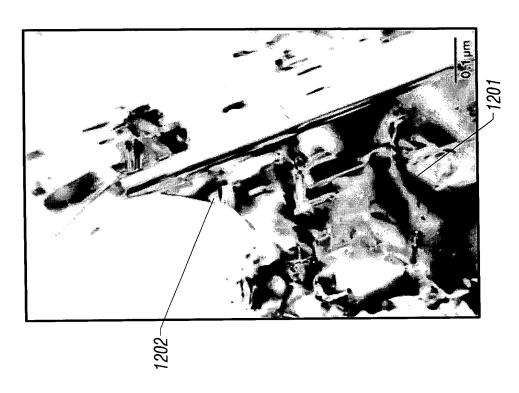
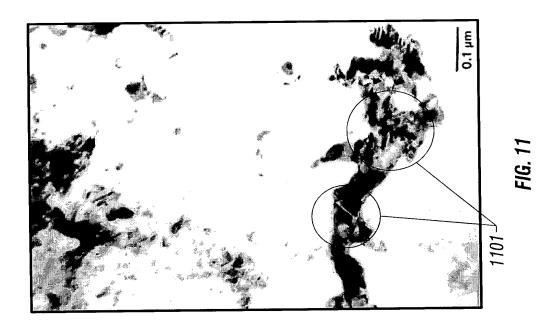


FIG. 10

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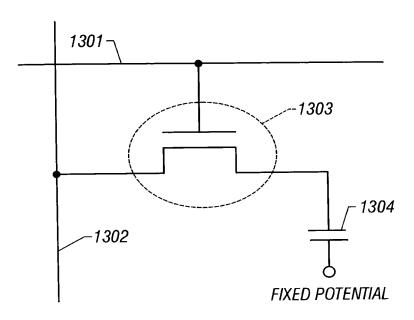


FIG. 13A

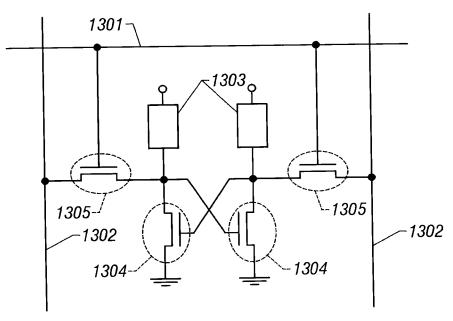


FIG. 13B

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Matter No.: 07977-188002): Yamazaki et al. DUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME

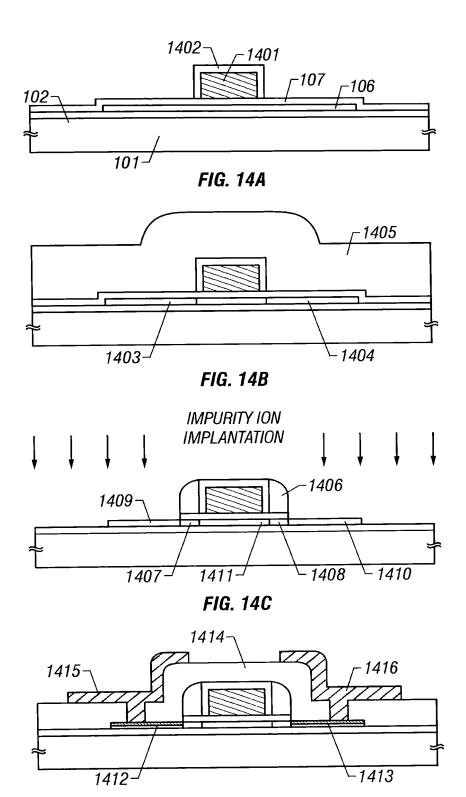


FIG. 14D

Matter No.: 07977-188002 nt(s): Yamazaki et al. ONDUCTOR DEVICE AND METHOD OF **UFACTURING THE SAME**

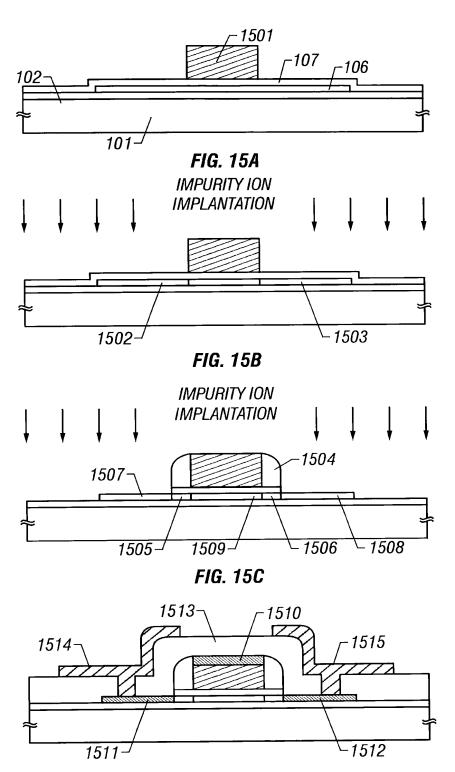
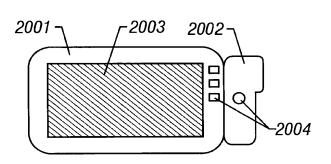


FIG. 15D

Matter No.: 07977-188002

Application of the state of the





2102 FIG. 16B

FIG. 16A

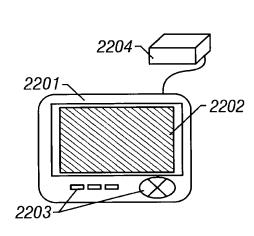
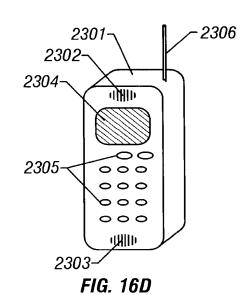


FIG. 16C



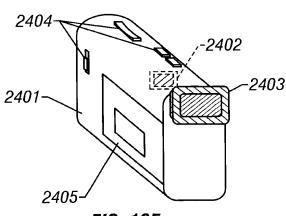


FIG. 16E

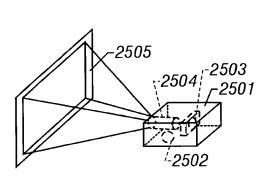


FIG. 16F